

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	BRS	L1	1338	micromechanical and pressure and (sensor transducer)	USPAT; US-PGPUB; DERWENT	2004/08/05 11:47	
2	BRS	L2	228	1 and semiconductor and diaphragm	USPAT; US-PGPUB; DERWENT	2004/08/05 11:48	
3	BRS	L3	0	2 and compensat\$3 near3 resistor	USPAT; US-PGPUB; DERWENT	2004/08/05 11:47	
4	BRS	L4	0	2 and compensat\$3 near resistor	USPAT; US-PGPUB; DERWENT	2004/08/05 11:47	
5	BRS	L5	2	1 and compensat\$3 near resistor	USPAT; US-PGPUB; DERWENT	2004/08/05 11:47	
6	BRS	L6	252	micromechanical and pressure and (sensor transducer).ti.	USPAT; US-PGPUB; DERWENT	2004/08/05 11:47	
7	BRS	L8	0	7 and compensat\$3 near3 resistor	USPAT; US-PGPUB; DERWENT	2004/08/05 11:49	

	Error Definition	Er ro rs
1		0
2		0
3		0
4		0
5		0
6		0
7		0

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
8	BRS	L11	2	7 and measur\$3 near3 resistor	USPA T; US-P GPUB ; DERW ENT	2004/08/0 5 11:50	
9	BRS	L9	5	6 and compensat\$3 near3 resistor	USPA T; US-P GPUB ; DERW ENT	2004/08/0 5 11:50	
10	BRS	L7	59	6 and semiconductor and diaphragm	USPA T; US-P GPUB ; DERW ENT	2004/08/0 5 11:50	
11	BRS	L10	17	6 and wheatstone	USPA T; US-P GPUB ; DERW ENT	2004/08/0 5 11:53	
12	BRS	L12	399	quadratic near3 (component element)	USPA T; US-P GPUB ; DERW ENT	2004/08/0 5 11:53	
13	BRS	L13	26652	linear near3 (component element)	USPA T; US-P GPUB ; DERW ENT	2004/08/0 5 11:54	
14	BRS	L14	94	12 and 13	USPA T; US-P GPUB ; DERW ENT	2004/08/0 5 11:54	

	Error Definition	Er ro rs
8		0
9		0
10		0
11		0
12		0
13		0
14		0

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
15	BRS	L15	4	14 and pressure near2 (sensor transducer)	USPA T; US-P GPUB ; DERW ENT	2004/08/0 5 11:54	
16	BRS	L16	1	14 and pressure near2 (sensor transducer).ti.	USPA T; US-P GPUB ; DERW ENT	2004/08/0 5 11:55	

	Error Definition	Er ro rs
15		0
16		0